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## BIB DATA SHEET

CONFIRMATION NO. 2837

SERIAL NUMBER	FILING or 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.		
10/554,204	12/13/2005	428	1794	2005-1690A		
<b>RULE</b>						
<b>APPLICANTS</b> Masahiro Goto, Tsukuba-shi, JAPAN; Akira Kasahara, Tsukuba-shi, JAPAN; Tetsuo Oishi, Tsukuba-shi, JAPAN; Masahiro Tosa, Tsukuba-shi, JAPAN; Kazuhiro Yoshihara, Tsukuba-shi, JAPAN;						
<b>** CONTINUING DATA *****</b> This application is a 371 of PCT/JP04/05902 04/23/2004						
<b>** FOREIGN APPLICATIONS *****</b> JAPAN 2003-120461 04/24/2003						
<b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b> 02/05/2008						
Foreign Priority claimed	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	<input type="checkbox"/> Met after Allowance	<b>STATE OR COUNTRY</b>	<b>SHEETS DRAWINGS</b>	<b>TOTAL CLAIMS</b>	<b>INDEPENDENT CLAIMS</b>
35 USC 119(a-d) conditions met	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	Initials	JAPAN	5	9	2
Verified and Acknowledged	/TIMOTHY M SPEER/ Examiner's Signature					
<b>ADDRESS</b> WENDEROTH, LIND & PONACK, L.L.P. 2033 K STREET N. W. SUITE 800 WASHINGTON, DC 20006-1021 UNITED STATES						
<b>TITLE</b> Copper Oxide Thin Film Low-Friction Material And Film-Forming Method Therefor						
<b>FILING FEE RECEIVED</b> 1030	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:			<input type="checkbox"/> All Fees		
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